## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of Suing-Jun LIM Serial No.

[Division of Serial No. 10/178,306, filed June 25, 2002]

Filed: March 25, 2004

For: PHOTOLITHOGRAPHY PROCESSING SYSTEM AND METHOD THEREOF

## CONFIRMATION CLAIM FOR CONVENTION PRIORITY

Commissioner for Patents Alexandria, VA 22313-1450

Sir:

The benefit of the filing date of the following prior foreign application filed in the following foreign country is hereby requested, and the right of priority provided in 35 U.S.C. §119 is hereby claimed:

## Application No. 2001-41473 - filed 11 July 2001 - Republic of Korea

In support of this claim, a certified copy of said original foreign application was filed in parent application Serial No. 10/178,306 on June 25, 2002.

Acknowledgment of applicant's claim for priority and receipt of the certified priority document is solicited.

Respectfully submitted,

Date: March 25, 2004

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